

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	Group Art Unit:
)	
Junichi SATO et al.)	Examiner:
)	
Application No.:)	
)	
Filed:)	
)	
For: SEMICONDUCTOR THIN FILM)	
AND METHOD OF FABRICATING)	
SEMICONDUCTOR THIN FILM,)	
APPARATUS FOR FABRICATING)	
SINGLE CRYSTAL)	
SEMICONDUCTOR THIN FILM,)	
AND METHOD OF FABRICATING)	
SINGLE CRYSTAL THIN FILM,)	
SINGLE CRYSTAL THIN FILM)	
SUBSTRATE, AND)	
SEMICONDUCTOR DEVICE)	

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT PURSUANT TO 37 C.F.R. § 1.53(b)

Dear Sir:

The above-identified application is a divisional of Application No. 09/946,898 filed September 5, 2001. Please amend the instant application as follows.